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# **SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT**

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of

1

Application Number

10/616,044

Filing Date

July 8, 2003

First Named Inventor

Yang, et al.

Group Art Unit

1753

Examiner Name

Luan V. Van

Attorney Docket Number

APPM/007669.P2/PPC/ECPI/RKK

Submission Date

October 12, 2005

## **U.S. PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
LV	A1	US 6024856	02/15/2000	Haydu, et al.	
	A2				
	A3				
	A4				
	A5				
	A6				
	A7				
	A8				
	A9				

## **FOREIGN PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)				
LV	B1	WO 2005/007933 A1	01/27/2005	Yang, et al.		
LV	B2	WO 2004/003410 A1	01/08/2004	Titel, et al.		
LV	B3	WO 2001/096632 A3	12/20/2001	Cheung, et al.		

## **NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T <sup>2</sup>
LV	C1	International Search Report dated August 22, 2005 regarding International Application No. PCT/US2005/016123 (APPM/007669PC04)	

Examiner

/Luan Van/ (07/31/2006)

Date Considered

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. <sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

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**SUPPLEMENTAL INFORMATION  
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APPLICANT**

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**Complete if Known**

Application Number	10/616,044
Filing Date	July 8, 2003
First Named Inventor	Yang, et al.
Art Unit	1753
Examiner Name	Nam X. NGuyen
Attorney Docket Number	AMAT/7669.P2/CMP/ECR/RKK

**NON PATENT LITERATURE DOCUMENTS**

Examiner Initials *	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
LV	C1	Colombo; "Wafer Back Surface Film Removal," Central R&D, SGS-THOMSON Microelectronics, Agate Italy	
LV	C2	Pitney, "Ney Contact Manual" October 1974	
LV	C3	Semitool Product Catalog (on-line) October 27, 1998	
LV	C4	Singer, "Copper Has Enormous Benefits When Compared to Aluminum, but its Implementation Requires Some Fundamental Changes in Process Technologies," Semiconductor International June 1998.	
LV	C5	Singer, "Wafer Processing," Semiconductor International June 1998.	
LV	C6	PCT International Search Report from International Application No. PCT/US 2004/022183, dated October 15, 2004.	

Examiner Signature	/Luan Van/ (07/31/2006)	Date Considered	
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